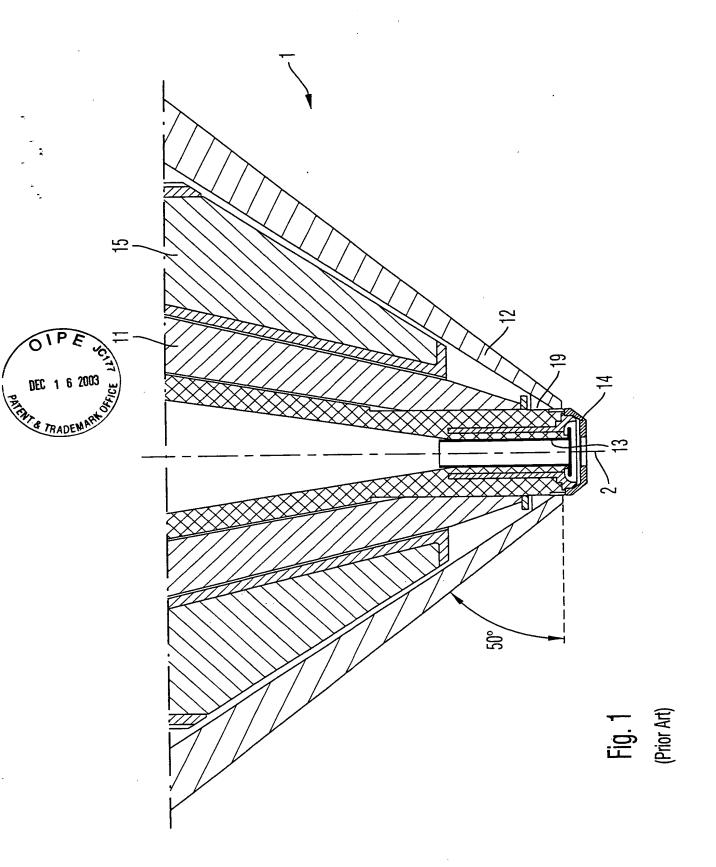
SYSTEM AND ELECTRON MICROSCOPY SYSTEM

INVENTOR(S): DIRK PREIKSZAS ET AL. APPLICATION SERIAL NO: 007413-058

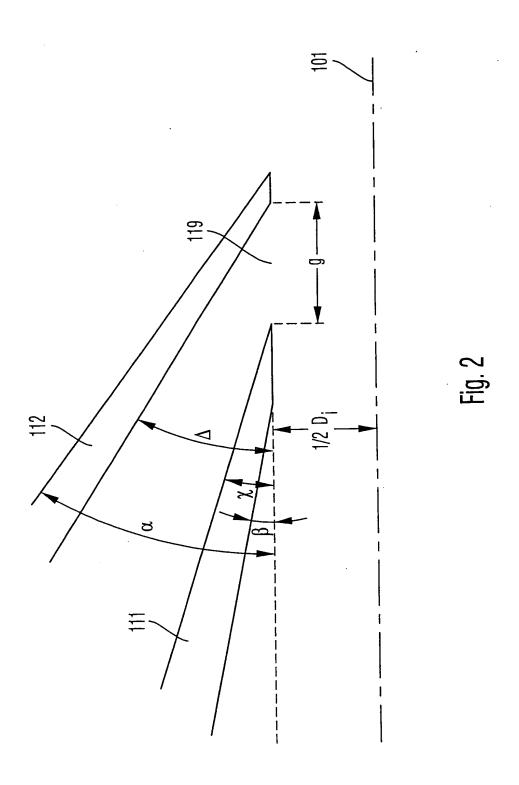
SHEET 1 of 8



SYSTEM AND ELECTRON MICROSCOPY SYSTEM

INVENTOR(S): DIRK PREIKSZAS ET AL. APPLICATION SERIAL NO: 007413-058

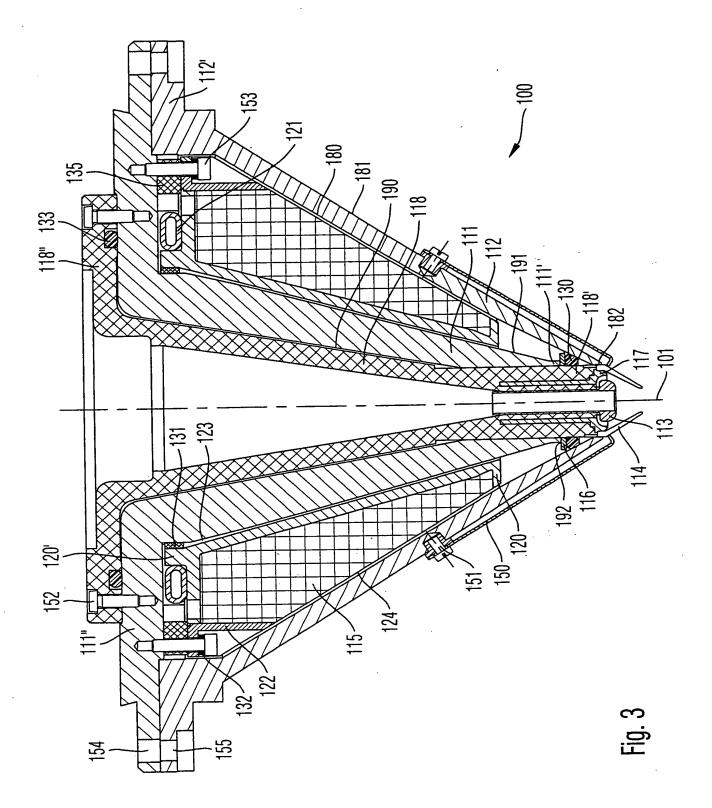
SHEET 2 of 8



APPLN. FILING DATE: JULY 16, 2003
TITLE: OBJECTIVE LENS FOR AN ELECTRON MICROSCOPY
SYSTEM AND ELECTRON MICROSCOPY SYSTEM

INVENTOR(S): DIRK PREIKSZAS ET AL. APPLICATION SERIAL NO: 007413-058

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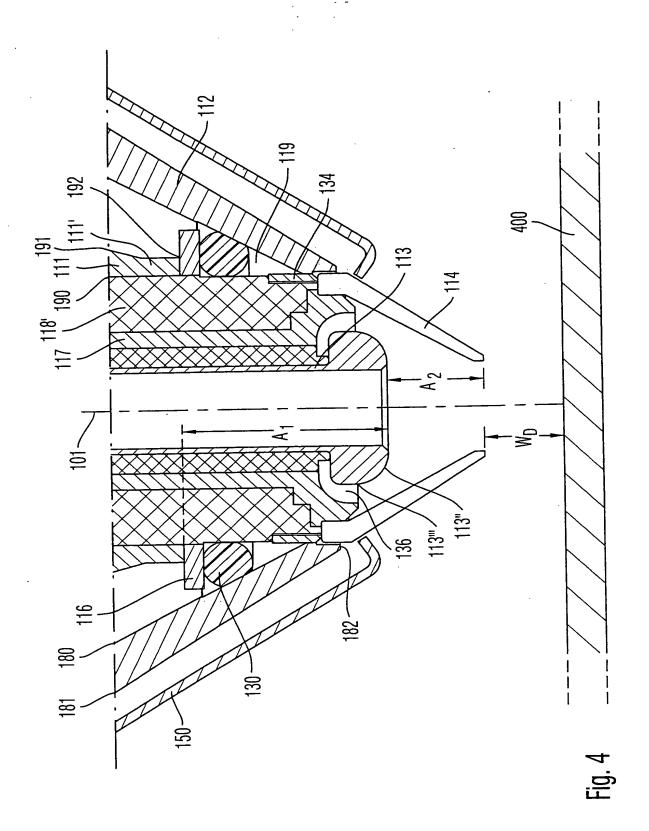


SYSTEM AND ELECTRON MICROSCOPY SYSTEM

INVENTOR(S): DIRK PREIKSZAS ET AL.

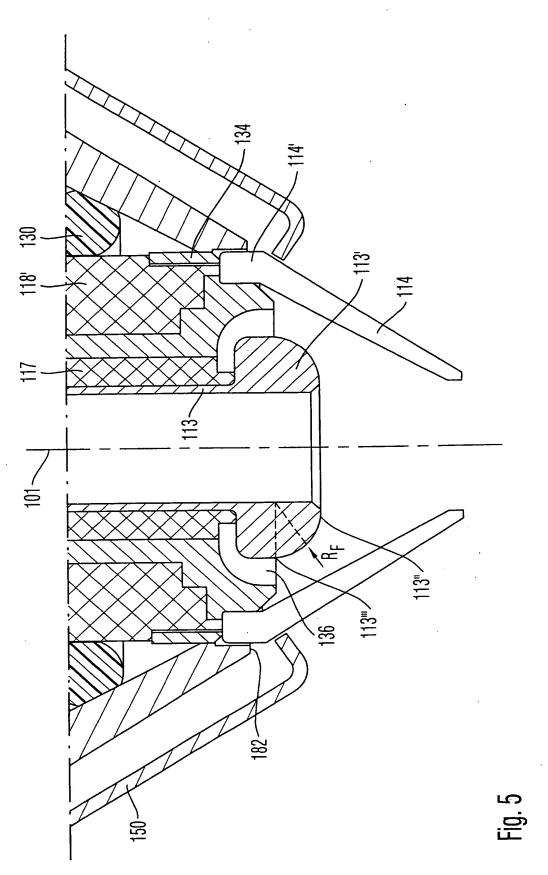
APPLICATION SERIAL NO: 007413-058

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APPLN. FILING DATE: JULY 16, 2003
TITLE: OBJECTIVE LENS FOR AN ELECTRON MICROSCOPY
SYSTEM AND ELECTRON MICROSCOPY SYSTEM
INVENTOR(S): DIRK PREJKSZAS ET AL.

APPLICATION SERIAL NO: 007413-058 SHEET 5 of 8



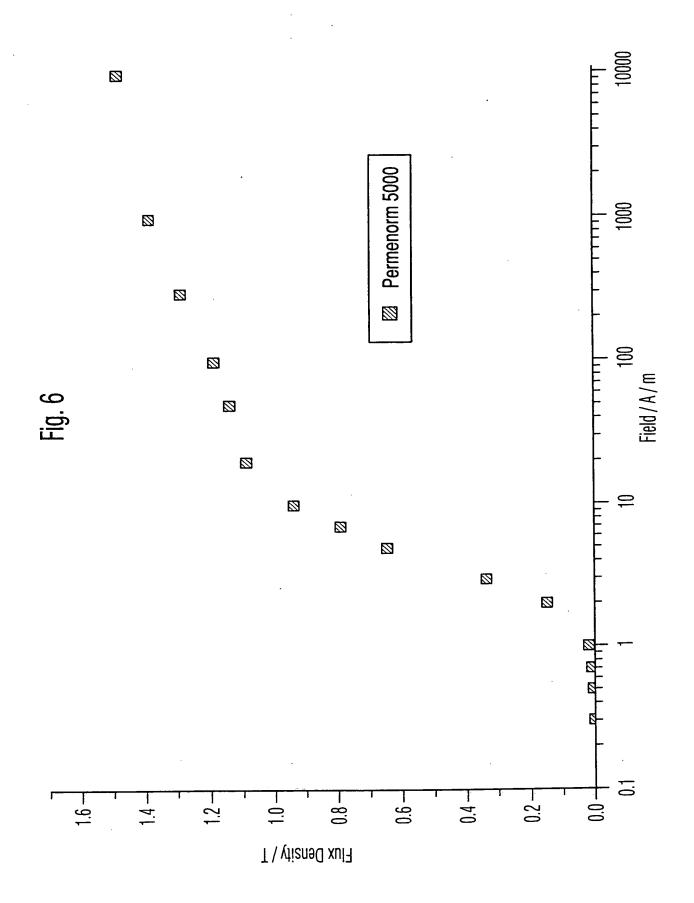
APPLN. FILING DATE: JULY 16, 2003

TITLE: OBJECTIVE LENS FOR AN ELECTRON MICROSCOPY

SYSTEM AND ELECTRON MICROSCOPY SYSTEM INVENTOR(S): DIRK PREIKSZAS ET AL.

APPLICATION SERIAL No: 007413-058

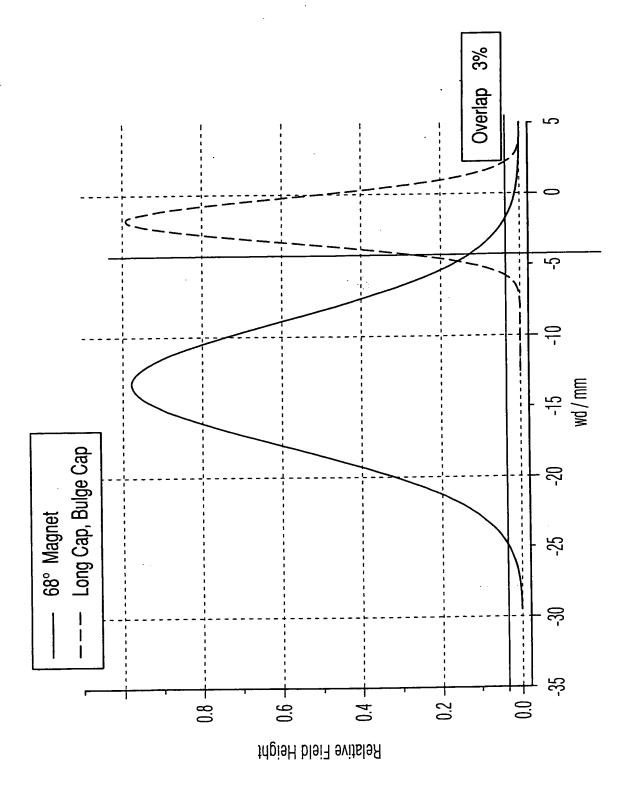
SHEET 6 of 8



SYSTEM AND ELECTRON MICROSCOPY SYSTEM

Inventor(s): Dirk Preikszas et al. Application Serial No: 007413-058





APPLN. FILING DATE: JULY 16, 2003
TITLE: OBJECTIVE LENS FOR AN ELECTRON MICROSCOPY
SYSTEM AND ELECTRON MICROSCOPY SYSTEM

INVENTOR(S): DIRK PREIKSZAS ET AL. APPLICATION SERIAL NO: 007413-058

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